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APPLICANTS

Mutsumi Kimura, Kyotanabe-shi, JAPAN;

** CONTINUING DATA *None* *PD*

** FOREIGN APPLICATIONS *YES* *PD*
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verifier and Acknowledged <i>Xiang Shun</i> Examiner's Signature <i>PD</i> Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 1
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ADDRESS

25944
 OLIFF & BERRIDGE, PLC
 P.O. BOX 19928
 ALEXANDRIA, VA
 22320

TITLE

Method of manufacturing thin film element, thin film transistor circuit substrate, active matrix display device, electro-optical device, and electronic apparatus

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